

Notice of References Cited	Application/Control No.	Applicant(s)/Patent Under Reexamination	
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	Examiner Cephia D. Toomer	Art Unit 1714	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,864,001	03-2005	Zhang et al.	429/15
*	B	US-6,604,598	08-2003	Rohde et al.	180/271
	C	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
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	M	US-			

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	O	WO0021772	04-2000	WIPO		
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
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